

Electronic Patent Application Fee Transmittal

Application Number:	10828882				
Filing Date:	21-Apr-2004				
Title of Invention:	Semiconductor thin film and method of fabricating semiconductor thin film, apparatus for fabricating single crystal semiconductor thin film, and method of fabricating single crystal thin film, single crystal thin film substrate, and semiconductor device				
First Named Inventor/Applicant Name:	Junichi Sato				
Filer:	David E. Crawford/Drenda Nemeth				
Attorney Docket Number:	09792909-5921				
Filed as Large Entity					
Utility Filing Fees					
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:					
Pages:					
Claims:					
Miscellaneous-Filing:					
Petition:					
Patent-Appeals-and-Interference:					
Post-Allowance-and-Post-Issuance:					
Extension-of-Time:					
Extension - 2 months with \$0 paid	1252	1	450	450	

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	790	790
Total in USD (\$)				1240